

FORM PTO-1449 (modified)  
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Atty. Dkt. No.	M#	Client Ref.
081468	0308407	P-1813.000-US
Applicant: PELLENS		
Appln. No.: 10/783,034		
Filing Date: February 23, 2004		
Examiner: Kevin V. Quinto   Group Art Unit: 2826		

**INFORMATION DISCLOSURE STATEMENT  
BY APPLICANT**

Date: August 15, 2007

Page **1** of **1**

**U.S. PATENT DOCUMENTS**

Examiner's Initials*	Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
AR						
BR						
CR						
DR						
ER						
FR						
GR						
HR						
IR						
JR						
KR						
LR						
MR						
NR						

**FOREIGN PATENT DOCUMENTS**

	Document Number	Date MM/YYYY	Country	Inventor Name		English Abstract	Translation Readily Available
						Enclosed	No
OR							
PR							
QR							
RR							
SR							
TR							
UR							
VR							
WR							
XR							

**OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)**

/KQ/	YR	N. SAMOTO ET AL., Sub-0.1-um T-Shaped Gate Fabrication Technology Using Mixing-Layer Sidewalls in a Double-Layer Resist System, J. Vac. Sci Technology, American Vacuum Society, Vol. 12 ( No. 6), pp. 3673-3676, (November/December 1994).			
	ZR				

Examiner /Kevin Quinto/

Date Considered: 10/28/2007

\*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.



PTO/SB/08b (08-03)

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Substitute for form 1449B/PTO

## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Sheet

1

of

Complete if Known	
Application Number	10/783,034
Filing Date	02/23/2004
First Named Inventor	RUDY JAN MARIA PELLENS
Art Unit	2826
Examiner Name	Fetsam Abraham Kevin Quinto
Attorney Docket Number	081468-0308407

### NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
	See Attachment 1		
/KQ/		HUONG-MING LEE, ET AL., New Nanometer T-Gate Fabricated by Thermally Relflowed Resist Technique, Japan Journal of Applied Physics, The Japan Society of Applied Physics, Vol. 41 ( No. 12B), pp. L1508-L1510, (December 15, 2002).	
/KQ/		PCT International Search Report, (dated November 4, 2005).	

Examiner Signature

/Kevin Quinto/

Date Considered

10/28/2007

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1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached. This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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